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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of	)	PROCESS FOR PREPARING
	)	NANOSTRUCTURED MATERIALS
Sarkas et al.	)	OF CONTROLLED SURFACE
	)	CHEMISTRY
Application No.	)	
	)	Group Art Unit:
Filing Date:	)	Examiner:

Commissioner for Patents  
P.O. Box 1450  
Mail Stop: Patent Application  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Applicant hereby submits the following Preliminary Amendment to the above-referenced application.

Please amend the Specification as set fourth in the following amendment.